



# CERTIFICATE OF ACCREDITATION

**The ANSI National Accreditation Board**

Hereby attests that

**Productivity Quality, Inc. / Advanced Inspection Services, LLC**  
15150 25th Ave. N., Suite 200  
Plymouth, MN 55447

(and the satellite location listed on the scope)

Fulfils the requirements of

**ISO/IEC 17025:2017**

In the fields of

**DIMENSIONAL MEASUREMENT and CALIBRATION**

This certificate is valid only when accompanied by a current scope of accreditation document.  
The current scope of accreditation can be verified at [www.anab.org](http://www.anab.org).

Jason Stine, Vice President

Expiry Date: 15 January 2026

Certificate Number: ACT-1608



This laboratory is accredited in accordance with the recognized International Standard ISO/IEC 17025:2017.  
This accreditation demonstrates technical competence for a defined scope and the operation of a laboratory quality management system (refer to joint ISO-ILAC-IAF Communiqué dated April 2017).



## SCOPE OF ACCREDITATION TO ISO/IEC 17025:2017

### Productivity Quality, Inc. / Advanced Inspection Services, LLC

15150 25th Ave N. Suite 200

Plymouth, MN 55447

Adam Clark

763-249-8132

### DIMENSIONAL MEASUREMENT

Valid to: **January 15, 2026**

Certificate Number: **ACT-1608**

#### 1 Dimensional

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Dimensional Measurement 1D	Up to 24 in	(590 + 0.2L) µin	Dial Height
	Up to 12 in	514 µin	Gage Calipers
	Up to 3.2 in	124 µin	Micrometers
	Up to 0.008 in	120 µin	Dial Indicator
	Up to 0.03 in	310 µin	Dial Indicator
	Up to 2 in	120 µin	Drop Indicator
	Up to 1 in	116 µin	Gage Pins
	Up to 6 in	590 µin	Depth Micrometer

#### 2 Dimensional

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Dimensional Measurement 2D	Small Hole Dia. 2-8µm	0.2 µm	
	Up to 0.22 mm	(0.1 + 1.2L) µm	
	Up to 0.44 mm	(0.18 + 0.3L) µm	
	Up to 1.1 mm	(0.5 + 0.14L) µm	
Single FOV (XY)	Up to 2.2 mm	(0.86 + 0.25L) µm	Sensofar S-Neox
	Up to 4.4 mm	(1.7 + 0.18L) µm	
Step (Z)	Up to 1 mm	(0.007 + 4.3L) µm	
	Up to 11 in	(45 + 1.3L) µin	View Summit 600
Extended Range	Up to 30 in	(60 + 2.1L) µin	View Summit 600

### 3 Dimensional

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Dimensional Measurement 3D <sup>1</sup>	8 ft spherical volume Up to 708 in	(500 + 2.7L) µin (1 100 + 3.2L) µin	Romer Absolute CMM Leica Laser Tracker (MR) w / T-probe
	Up to 99 in	(78 + 3.6L) µin (120 +3.6L) µin	Hexagon 122210
	Up to 45 mm Up to 45 mm	(5 + 0.4L) µm (6 + 0.6L) µm	EasyTom CT

### Dimensional Measurement - Other

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Form Roundness	Up to 100 µin (100 to 500) µin	4.8 µin 53 µin	Mitutoyo RA2200 AH Roundness Tester
Cylindricity	Up to 100 µin (100 to 500) µin	39 µin 66 µin	Mitutoyo RA2200 AH Roundness Tester
Surface Finish (contact) Surface Finish (non-contact)	Up to 500 µin Up to 500 µin	3.9 µin 1.2 µin	Mitutoyo CV4500 Sensofar S Neox
Contour	Up to 4 in	(112 +24L) µin	Mitutoyo Contracer

### Satellite location

15300 25th Ave N. Suite 200  
Plymouth, MN 55447

## DIMENSIONAL MEASUREMENT

### 3 Dimensional

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Dimensional Measurement 3D Single Point Scanning Performance	Up to 67 in Up to 67 in	(12+ 0.73L) µin (38 + 0.42L) µin	Leitz Infinity Leitz Infinity

## CALIBRATION

### Chemical Quantities

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Conductivity Meters	84.2 $\mu\text{S}/\text{cm}$ 1 418 $\mu\text{S}/\text{cm}$ 10 010 $\mu\text{S}/\text{cm}$ 100 300 $\mu\text{S}/\text{cm}$	0.7 $\mu\text{S}/\text{cm} + 0.6\text{R}$ 6 $\mu\text{S}/\text{cm} + 0.6\text{R}$ 37 $\mu\text{S}/\text{cm} + 0.6\text{R}$ 370 $\mu\text{S}/\text{cm} + 0.6\text{R}$	Conductivity Solutions
pH Meters	4 pH 7 pH 10 pH	0.017 pH + 0.6R 0.014 pH + 0.6R 0.027 pH + 0.6R	pH Buffer Solutions
Refractometers	(1.345, 1.464) nD	0.000 55 nD + 0.6R	Refractive Index Solutions

### Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Voltage - Source	Up to 330 mV 330 mV to 3 V (3 to 33) V (30 to 330) V (100 to 1 020) V	0.78 $\mu\text{V} + 16 \mu\text{V/V}$ 1.7 $\mu\text{V} + 8.6 \mu\text{V/V}$ 17 $\mu\text{V} + 9.3 \mu\text{V/V}$ 0.13 mV + 14 $\mu\text{V/V}$ 1.3 mV + 14 $\mu\text{V/V}$	Fluke 5522A
DC Voltage - Measure	Up to 200 mV 200 mV to 2 V (2 to 20) V (20 to 200) V 200 V to 1 kV	0.1 $\mu\text{V} + 5 \mu\text{V/V}$ 0.4 $\mu\text{V} + 3.5 \mu\text{V/V}$ 4 $\mu\text{V} + 3.5 \mu\text{V/V}$ 40 $\mu\text{V} + 5.5 \mu\text{V/V}$ 0.5 mV + 5.5 $\mu\text{V/V}$	Fluke 8508A
	(1 to 60) kV	0.51 mV/V	Fluke 8846A and Ross Eng Divider
DC Current - Source	Up to 330 $\mu\text{A}$ 330 $\mu\text{A}$ to 3.3 mA (3.3 to 33) mA (33 to 330) mA 330 mA to 1.1 A (1.1 to 3) A (3 to 11) A (11 to 20.5) A	16 nA + 0.12 mA/A 40 nA + 78 $\mu\text{A/A}$ 0.21 $\mu\text{A} + 78 \mu\text{A/A}$ 2.1 $\mu\text{A} + 78 \mu\text{A/A}$ 32 $\mu\text{A} + 0.16 \text{mA/A}$ 32 $\mu\text{A} + 0.3 \text{mA/A}$ 0.4 mA + 0.39 mA/A 0.59 mA + 0.78 mA/A	Fluke 5522A
	(20.5 to 150) A (150 to 550) A (550 to 1 000) A	0.14 A + 5.1 mA/A 0.5 A + 5.1 mA/A 0.5 A + 5.1 mA/A	Fluke 5522A and Fluke 50 Turn Current Coil

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Current - Measure	Up to 100 nA (0.1 to 1) $\mu$ A (1 to 10) $\mu$ A	0.048 nA + 36 $\mu$ A/A 0.048 nA + 24 $\mu$ A/A 0.12 nA + 24 $\mu$ A/A	HP3458A
	(10 to 200) $\mu$ A 200 $\mu$ A to 2 mA (2 mA to 20) mA (20 to 200) mA 200 mA to 2 A (2 to 20) A	0.4 nA + 12 $\mu$ A/A 4 nA + 12 $\mu$ A/A 40 nA + 14 $\mu$ A/A 0.8 $\mu$ A + 48 $\mu$ A/A 16 $\mu$ A + 0.19 mA/A 0.4 mA + 0.4 mA/A	Fluke 8508A
	(20 to 100) A (100 to 600) A	0.9 mA/A 1.0 mA/A	Fluke 8508A with 100A Murata, and 600A Empro Shunts
AC Voltage - Source	(1 to 33) mV (10 to 45) Hz 45 Hz to 10 kHz (10 to 20) kHz (20 to 50) kHz (50 to 100) kHz (100 to 500) kHz (33 to 330) mV (10 to 45) Hz 45 Hz to 10 kHz (10 to 20) kHz (20 to 50) kHz (50 to 100) kHz (100 to 500) kHz 330 mV to 3.3 V (10 to 45) Hz 45 Hz to 10 kHz (10 to 20) kHz (20 to 50) kHz (50 to 100) kHz (100 to 500) kHz (3.3 to 33) V (10 to 45) Hz 45 Hz to 10 kHz (10 to 20) kHz (20 to 50) kHz (50 to 100) kHz	4.7 $\mu$ V + 0.62 mV/V 4.7 $\mu$ V + 0.12 mV/V 4.7 $\mu$ V + 0.16 mV/V 4.7 $\mu$ V + 0.78 mV/V 9.4 $\mu$ V + 2.8 mV/V 39 $\mu$ V + 6.2 mV/V  6.3 $\mu$ V + 0.24 mV/V 6.3 $\mu$ V + 0.12 mV/V 6.3 $\mu$ V + 0.13 mV/V 6.3 $\mu$ V + 0.28 mV/V 25 $\mu$ V + 0.62 mV/V 55 $\mu$ V + 1.6 mV/V  40 $\mu$ V + 0.24 mV/V 47 $\mu$ V + 0.12 mV/V 47 $\mu$ V + 0.15 mV/V 40 $\mu$ V + 0.24 mV/V 97 $\mu$ V + 0.55 mV/V 0.47 mV + 1.9 mV/V  0.51 mV + 0.24 mV/V 0.47 mV + 0.12 mV/V 0.47 mV + 0.19 mV/V 0.47 mV + 0.28 mV/V 1.3 mV + 0.7 mV/V	Fluke 5522A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage - Source	(33 to 330) V 45 Hz to 1 kHz (1 to 10) kHz (10 to 20) kHz (20 to 50) kHz (50 to 100) kHz (330 to 1 020) V 45 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz	1.7 mV + 0.15 mV/V 4.7 mV + 0.16 mV/V 4.7 mV + 0.2 mV/V 4.7 mV + 0.24 mV/V 39 mV + 1.6 mV/V  9.7 mV + 0.24 mV/V 9.7 mV + 0.2 mV/V 9.7 mV + 0.24 mV/V	Fluke 5522A
AC Voltage – Measure	Up to 10 mV (1 to 40) Hz 40 Hz to 1 kHz (1 to 20) kHz (20 to 50) kHz (50 to 100) kHz (100 to 300) kHz (10 to 100) mV (1 to 40) Hz 40 Hz to 1 kHz (1 to 20) kHz (20 to 50) kHz (50 to 100) kHz (100 to 300) kHz 300 kHz to 1 MHz	3.6 $\mu$ V + 0.36 mV/V 1.3 $\mu$ V + 0.24 mV/V 1.3 $\mu$ V + 0.36 mV/V 1.3 $\mu$ V + 1.2 mV/V 1.3 $\mu$ V + 6 mV/V 2.4 $\mu$ V + 48 mV/V  4.8 + 83 $\mu$ V/V 2.4 $\mu$ V + 83 $\mu$ V/V 2.4 $\mu$ V + 0.17 mV/V 2.4 $\mu$ V + 0.36 mV/V 2.4 $\mu$ V + 0.95 mV/V 12 $\mu$ V + 3.6 mV/V 12 $\mu$ V + 12 mV/V	HP3458A
	Up to 200 mV (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz  200 mV to 2 V (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz (100 to 300) kHz 300 kHz to 1 MHz	14 $\mu$ V + 0.17 mV/V 4 $\mu$ V + 0.14 mV/V 4 $\mu$ V + 0.12 mV/V 2 $\mu$ V + 0.11 mV/V 4 $\mu$ V + 0.14 mV/V 8 $\mu$ V + 0.64 mV/V 20 $\mu$ V + 0.77 mV/V  0.12 mV + 0.15 mV/V 20 $\mu$ V + 0.12 mV/V 20 $\mu$ V + 90 $\mu$ V/V 20 $\mu$ V + 75 $\mu$ V/V 20 $\mu$ V + 0.11 mV/V 40 $\mu$ V + 0.22 mV/V 0.2 mV + 0.57 mV/V 2 mV + 3 mV/V 20 mV + 10 mV/V	Fluke 8508A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Measure	(2 to 20) V (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz (100 to 300) kHz 300 kHz to 1 MHz  (20 to 200) V (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz (100 to 300) kHz 300 kHz to 1 MHz  (200 to 1 000) V (1 to 10) Hz (10 to 40) Hz 40 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz	1.2 mV + 0.15 mV/V 0.2 mV + 0.12 mV/V 0.2 mV + 90 µV/V 0.2 mV + 75 µV/V 0.2 mV + 0.11 mV/V 0.4 mV + 0.22 mV/V 2 mV + 0.57 mV/V 20 mV + 3 mV/V 0.2 V + 10 mV/V  12 mV + 0.15 mV/V 2 mV + 0.12 mV/V 2 mV + 90 µV/V 2 mV + 75 µV/V 2 mV + 0.11 mV/V 4 mV + 0.22 mV/V 20 mV + 0.57 mV/V 0.2 V + 3 mV/V 2 V + 10 mV/V  70 mV + 0.15 mV/V 20 mV + 0.12 mV/V 20 mV + 0.12 mV/V 40 mV + 0.23 mV/V 0.2 V + 0.58 mV/V	Fluke 8508A
AC Voltage - Measure	(1 to 60) kV 60 Hz	2.8 mV/V	Fluke 8846A and Ross Eng Divider

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current - Source	(29 to 330) $\mu$ A (10 to 20) Hz (20 to 45) Hz 45 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (10 to 30) kHz 330 $\mu$ A to 3.3 mA (10 to 20) Hz (20 to 45) Hz 45 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (10 to 30) kHz (3.3 to 33) mA (10 to 20) Hz (20 to 45) Hz 45 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (10 to 30) kHz (33 to 330) mA (10 to 20) Hz (20 to 45) Hz 45 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (10 to 30) kHz (330 mA to 1.1) A (10 to 45) Hz 45 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (1.1 to 3) A (10 to 45) Hz 45 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (3 to 11) A (45 to 100) Hz 100 Hz to 1 kHz (1 to 5) kHz (11 to 20.5) A (45 to 100) Hz 100 Hz to 1 kHz (1 to 5) kHz	78 nA + 1.6 mA/A 78 nA + 1.2 mA/A 78 nA + 0.97 mA/A 0.12 $\mu$ A + 2.4 mA/A 0.16 $\mu$ A + 6.2 mA/A 0.31 $\mu$ A + 13 mA/A  0.12 $\mu$ A + 1.6 mA/A 0.12 $\mu$ A + 0.97 mA/A 0.12 $\mu$ A + 0.78 mA/A 0.16 $\mu$ A + 1.6 mA/A 0.24 $\mu$ A + 3.9 mA/A 0.47 $\mu$ A + 7.8 mA/A  1.6 $\mu$ A + 1.4 mA/A 1.6 $\mu$ A + 0.7 mA/A 1.6 $\mu$ A + 0.31 mA/A 1.6 $\mu$ A + 0.62 mA/A 1.6 $\mu$ A + 1.6 mA/A 1.6 $\mu$ A + 3.1 mA/A  16 $\mu$ A + 1.4 mA/A 16 $\mu$ A + 0.7 mA/A 16 $\mu$ A + 0.31 mA/A 39 $\mu$ A + 0.78 mA/A 78 $\mu$ A + 1.6 mA/A 0.16 mA + 3.1 mA/A  78 $\mu$ A + 1.4 mA/A 78 $\mu$ A + 0.39 mA/A 0.78 mA + 4.7 mA/A 3.9 mA + 20 mA/A  78 $\mu$ A + 1.4 mA/A 78 $\mu$ A + 0.47 mA/A 78 $\mu$ A + 4.7 mA/A 3.9 mA + 20 mA/A  1.6 mA + 0.47 mA/A 1.6 mA + 0.78 mA/A 1.6 mA + 24 mA/A  3.9 mA + 0.93 mA/A 3.9 mA + 1.2 mA/A 3.9 mA + 24 mA/A	Fluke 5522A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current - Source	(20.5 to 150) A (45 to 65) Hz (65 to 440) Hz (150 to 1 000) A (45 to 65) Hz (65 to 440) Hz	0.25 A + 5.7 mA/A 0.25 A + 11 mA/A  0.9 A + 5.7 mA/A 0.9 A + 11 mA/A	Fluke 5522A and Fluke 50 Turn Current Coil
AC Current - Measure	Up to 200 $\mu$ A (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz 200 $\mu$ A to 2 mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz (2 to 20) mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz 20 to 200 mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz 200 mA to 2 A 10 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (2 to 20) A 10 Hz to 2 kHz (2 to 10) kHz	20 nA + 0.5 mA/A 20 nA + 0.5 mA/A 20 nA + 0.71 mA/A 20 nA + 4 mA/A  0.2 $\mu$ A + 0.31 mA/A 0.2 $\mu$ A + 0.3 mA/A 0.2 $\mu$ A + 0.71 mA/A 0.2 $\mu$ A + 4 mA/A  2 $\mu$ A + 0.31 mA/A 2 $\mu$ A + 0.3 mA/A 2 $\mu$ A + 0.71 mA/A 2 $\mu$ A + 4 mA/A  20 $\mu$ A + 0.31 mA/A 20 $\mu$ A + 0.29 mA/A 20 $\mu$ A + 0.63 mA/A  0.2 mA + 0.62 mA/A 0.2 mA + 0.74 mA/A 0.2 mA + 3 mA/A  2 mA + 0.82 mA/A 2 mA + 2.5 mA/A	Fluke 8508A
AC Current - Measure	(20 to 50) A 60 Hz	21 mA/A	Fluke 8508A and CTF-5RL
DC Power - Source	33mV to 1 020 V (0.33 to 330) mA 330 mA to 3 A (3 to 20.5) A	0.18 mW/W 0.18 mW/W 0.55 mW/W	Fluke 5522A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Power - Source	(33 to 330) mV (3.3 to 9) mA (9 to 33) mA (33 to 90) mA (90 to 330) mA (330 to 900) mA 900 mA to 2.2 A (2.2 to 4.5) A (4.5 to 20.5) A  330mV to 1 020 V (3.3 to 9) mA (9 to 33) mA (33 to 90) mA (90 to 330) mA (330 to 900) mA 900 mA to 2.2 A (2.2 to 4.5) A (4.5 to 20.5) A	1.1 mW/W 0.78 mW/W 1.1 mW/W 0.78 mW/W 1.1 mW/W 0.86 mW/W 1.1 mW/W 0.86 mW/W  0.93 mW/W 0.62 mW/W 0.93 mW/W 0.62 mW/W 0.86 mW/W 0.7 mW/W 0.93 mW/W 0.78 mW/W	Fluke 5522A
Resistance - Source	(0 to 11) Ω (11 to 33) Ω (33 to 110) Ω (110 to 330) Ω 330 Ω to 1.1 kΩ (1.1 to 3.3) kΩ (3.3 to 11) kΩ (11 to 33) kΩ  (33 to 110) kΩ (110 to 330) kΩ 330 kΩ to 1.1 MΩ (1.1 to 3.3) MΩ (3.3 to 11) MΩ (11 to 33) MΩ (33 to 110) MΩ (110 to 330) MΩ (330 to 1 100)MΩ	0.78 mΩ + 31 μΩ/Ω 1.2 mΩ + 24 μΩ/Ω 1.1 mΩ + 22 μΩ/Ω 1.6 mΩ + 22 μΩ/Ω 1.7 mΩ + 22 μΩ/Ω 16 mΩ + 22 μΩ/Ω 17 mΩ + 22 μΩ/Ω 0.16 Ω + 22 μΩ/Ω 0.17 Ω + 22 μΩ/Ω 1.6 Ω + 25 μΩ/Ω 1.7 Ω + 25 μΩ/Ω 24 Ω + 47 μΩ/Ω 40 Ω + 0.11 mΩ/Ω 2 kΩ + 0.2 mΩ/Ω 2.4 kΩ + 0.39 mΩ/Ω 78 kΩ + 2.4 mΩ/Ω 390 kΩ + 12 mΩ/Ω	Fluke 5522A
Resistance - Measure	Up to 500 mΩ	0.9 mΩ/Ω	Fluke 5522A and 8508A
Resistance - Measure	Up to 2 Ω (2 to 20) Ω (20 to 200) Ω (0.2 to 2) kΩ (2 to 20) kΩ (20 to 200) kΩ (0.2 to 2) MΩ (2 to 20) MΩ (20 to 200) MΩ (0.2 to 2)GΩ	4 μΩ + 17 μΩ/Ω 14 μΩ + 9.5 μΩ/Ω 50 μΩ + 8 μΩ/Ω 0.5 mΩ + 8 μΩ/Ω 5 mΩ + 8 μΩ/Ω 50 mΩ + 8 μΩ/Ω 5.9 Ω + 9 μΩ/Ω 0.12 kΩ + 20 μΩ/Ω 10 kΩ + 0.12 mΩ/Ω 1 MΩ + 1.6 mΩ/Ω	Fluke 8508A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Capacitance - Source	(220 to 400) pF 10 Hz to 10kHz 400 pF to 1.1 nF 10 Hz to 10 kHz (1.1 to 3.3) nF 10 Hz to 3 kHz (3.3 to 11) nF 10 Hz to 1 kHz (11 to 33) nF 10 Hz to 1 kHz (33 to 110) nF 10 Hz to 1 kHz (110 to 330) nF 10 Hz to 1 kHz 330 nF to 1.1 µF (10 to 60)0 Hz (1.1 to 3.3) µF (10 to 300) Hz (3.3 to 11) µF (10 to 150) Hz (11 to 33) µF (10 to 120) Hz (33 to 110) µF (10 to 8)0 Hz (110 to 330) µF (0 to 50) Hz (330 to 1.1) mF (0 to 20) Hz (1.1 to 3.3) mF (0 to 6) Hz (3.3 to 11) mF (0 to 2) Hz (11 to 33) mF (0 to 0.6) Hz (33 to 110) mF (0 to 0.2)Hz	7.8 pF + 3.9 mF/F 7.8 pF + 3.9 mF/F 7.8 pF + 3.9 mF/F 7.8 pF + 3.9 mF/F 7.8 pF + 2 mF/F 7.8 pF + 2 mF/F 7.8 pF + 2 mF/F 24 pF + 2 mF/F 0.78 nF + 2 mF/F 2.4 nF + 2 mF/F 7.8 nF + 2 mF/F 24 nF + 3.1 mF/F 78 nF + 3.5 mF/F 0.24 µF + 3.5 mF/F 0.78 µF + 3.5 mF/F 2.4 µF + 3.5 mF/F 7.8 µF + 3.5 mF/F 24 µF + 5.9 mF/F 78 µF + 8.6 mF/F	Fluke 5522A
Capacitance - Measure	Up to 1 nF (1 to 10) nF (10 to 100) nF 100 nF to 1 µF (1 to 10) µF (10 to 100) µF 100 µF to 1 mF (1 to 10) mF (10 to 100) mF	30 pF + 20 mF/F 62 pF + 10 mF/F 0.62 nF + 10 mF/F 8.5 nF + 10 mF/F 62 nF + 10 mF/F 0.76 µF + 10 mF/F 9.5 µF + 10 mF/F 76 µF + 10 mF/F 1.3 mF + 10 mF/F	Fluke 8846A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple – Source	Type B (600 to 800) °C (800 to 1 000) °C (1 000 to 1 550) °C (1 550 to 1 820) °C Type C (0 to 150) °C (150 to 650) °C (650 to 1 000) °C (1 000 to 1 800) °C (1 800 to 2 316) °C Type E (-250 to -100) °C (-100 to -25) °C (-25 to 350) °C (350 to 650) °C (650 to 1 000) °C Type J (-210 to -100) °C (-100 to -30) °C (-30 to 150) °C (150 to 760) °C (760 to 1 200) °C Type K (-200 to -100) °C (-100 to -25) °C (-25 to 120) °C (120 to 1 000) °C (1 000 to 1 372) °C Type L (-200 to -100) °C (-100 to 800) °C (800 to 900) °C	0.35 °C 0.27 °C 0.24 °C 0.26 °C 0.24 °C 0.21 °C 0.24 °C 0.39 °C 0.66 °C 0.39 °C 0.13 °C 0.11 °C 0.13 °C 0.17 °C 0.21 °C 0.13 °C 0.11 °C 0.14 °C 0.18 °C 0.26 °C 0.14 °C 0.13 °C 0.21 °C 0.31 °C 0.29 °C 0.21 °C 0.14 °C	Fluke 5522A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple – Source	Type N (-200 to -100) °C (-100 to -25) °C (-25 to 120) °C (120 to 410) °C (410 to 1 300) °C  Type R (0 to 250) °C (250 to 1 000) °C (1 000 to 1 400) °C (1 400 to 1 767) °C  Type S (0 to 250) °C (250 to 1 000) °C (1 000 to 1 400) °C (1 400 to 1 767) °C  Type T (-250 to -150) °C (-150 to 0) °C (0 to 120) °C (120 to 400) °C  Type U (-200 to 0) °C (0 to 600) °C	0.31 °C 0.18 °C 0.15 °C 0.14 °C 0.21 °C  0.45 °C 0.28 °C 0.26 °C 0.31 °C  0.37 °C 0.28 °C 0.29 °C 0.36 °C  0.49 °C 0.19 °C 0.13 °C 0.11 °C  0.44 °C 0.21 °C	Fluke 5522A
Electrical Simulation of RTDs – Source	Pt 385 100 Ω (-200 to 0) °C (0 to 100) °C (100 to 300) °C (300 to 400) °C (400 to 630) °C (630 to 800) °C  Pt 3926 100 Ω (-200 to 0) °C (0 to 100) °C (100 to 300) °C (300 to 400) °C (400 to 630) °C  Pt 3916 100 Ω (-200 to -190) °C (-190 to -80) °C (-80 to 0) °C (0 to 100) °C (100 to 260) °C (260 to 300) °C (300 to 400) °C (400 to 600) °C (600 to 630) °C	0.043 °C 0.057 °C 0.072 °C 0.08 °C 0.095 °C 0.18 °C  0.043 °C 0.057 °C 0.072 °C 0.08 °C 0.095 °C  0.2 °C 0.036 °C 0.043 °C 0.05 °C 0.057 °C 0.065 °C 0.072 °C 0.08 °C 0.18 °C	Fluke 5522A

## Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTDs – Source	Pt 385 200 Ω (-200 to -80) °C (-80 to 100) °C (100 to 260) °C (260 to 300) °C (300 to 600) °C (600 to 630) °C  Pt 385 500 Ω (-200 to -80) °C (-80 to 100) °C (100 to 260) °C (260 to 300) °C (300 to 400) °C (400 to 600) °C (600 to 630) °C  Pt 385 1000 Ω (-200 to 0) °C (0 to 100) °C (100 to 260) °C (260 to 300) °C (300 to 600) °C (600 to 630) °C  PtNi 385 120 Ω (-80 to 0) °C (0 to 100) °C (100 to 260) °C  Cu 427 10 Ω (-100 to 260) °C	0.31 °C 0.036 °C 0.043 °C 0.095 °C 0.11 °C 0.13 °C  0.036 °C 0.043 °C 0.05 °C 0.065 °C 0.065 °C 0.072 °C 0.087 °C  0.029 °C 0.036 °C 0.043 °C 0.05 °C 0.057 °C 0.18 °C  0.065 °C 0.065 °C 0.11 °C  0.24 °C	Fluke 5522A
Oscilloscope Leveled Sine Wave – Source	  Amplitude  5 mV to 5.5 V 50 kHz (Reference) 50 kHz to 100 MHz (100 to 300) MHz (300 to 600) MHz   Frequency  5 mV to 3.5 V (600 to 1 100) MHz  50 kHz to 600 MHz (600 to 1100) MHz	0.24 mV + 16 mV/V 0.24 mV + 28 mV/V 0.24 mV + 31 mV/V 0.24 mV + 47 mV/V  0.24 mV + 55 mV/V  5.8 kHz + 2 μHz/Hz 58 kHz + 2 μHz/Hz	Fluke 5522A SC1100

**Electrical – DC/Low Frequency**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Oscilloscope Voltage – Source	(1 to 25) mV (25 to 110) mV 110 mV to 2.2 V (2.2 to 6.6) V	31 $\mu$ V + 2 mV/V 32 $\mu$ V + 2 mV/V 66 $\mu$ V + 2 mV/V 0.58 mV + 2 mV/V	
DC Signal 50 $\Omega$	(1 to 25) mV (25 to 110) mV 110 mV to 2.2 V (2.2 to 11) V (11 to 130) V	31 $\mu$ V + 0.39 mV/V 32 $\mu$ V + 0.39 mV/V 66 $\mu$ V + 0.39 mV/V 0.58 mV + 0.39 mV/V 5.8 mV + 0.39 mV/V	
DC Signal 1 M $\Omega$	(1 to 25) mV (25 to 110) mV 110 mV to 2.2 V (2.2 to 11) V (11 to 130) V	31 $\mu$ V + 2 mV/V 32 $\mu$ V + 2 mV/V 66 $\mu$ V + 2 mV/V 0.58 mV + 2 mV/V	
Square Wave 50 $\Omega$	(1 to 25) mV (25 to 110) mV 110 mV to 2.2 V (2.2 to 6.6) V	31 $\mu$ V + 2 mV/V 32 $\mu$ V + 2 mV/V 66 $\mu$ V + 2 mV/V 0.58 mV + 2 mV/V	
Square Wave 1 M $\Omega$	(1 to 25) mV (25 to 110) mV 110 mV to 2.2 V (2.2 to 11) V (11 to 130) V	31 $\mu$ V + 0.78 mV/V 32 $\mu$ V + 0.78 mV/V 66 $\mu$ V + 0.78 mV/V 0.58 mV + 0.78 mV/V 5.8 mV + 0.78 mV/V	
Square Wave Frequency	(10 to 100) Hz 100 Hz to 1 kHz (1 to 10) kHz	5.8 mHz + 2 $\mu$ Hz/Hz 58 mHz + 2 $\mu$ Hz/Hz 0.58 Hz + 2 $\mu$ Hz/Hz	Fluke 5522A SC1100
Oscilloscope Pulse Generator – Source Pulse Width	(4 to 10) nS (10 to 500) nS	1.8 nS + 39 mS/S 1.9 nS + 39 mS/S	
Pulse Period	200 nS to 1 uS (1 to 10) uS (10 to 100) uS 100 uS to 1 mS (1 to 10) mS (10 to 20) mS	58 pS + 2 uS/S 0.58 nS + 2 uS/S 5.8 nS + 2 uS/S 58 nS + 2 uS/S 0.58 uS + 2 uS/S 5.8 uS + 2 uS/S	
Oscilloscope Wave Generator – Source Amplitude p-p	(1.8 to 100) mV (0.1 to 1) V (1 to 8) V (8 to 55) V	97 $\mu$ V + 24 mV/V 0.59 mV + 24 mV/V 5.8 mV + 24 mV/V 58 mV + 24 mV/V	
Frequency	10 Hz to 1 kHz (1 to 10) kHz (10 to 100) kHz	13 mHz + 20 $\mu$ Hz/Hz 59 mHz + 20 $\mu$ Hz/Hz 5.8 Hz + 20 $\mu$ Hz/Hz	

## Length – Dimensional Metrology

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Micrometers- O.D., Blade, Point, Spline, Tube, Disc, Depth, Indicating, Interchangeable, Bench and Pitch <sup>1</sup>	Up to 48 in Flatness Parallelism	(42 + 0.44L) µin 11 µin 16 µin	Gage Blocks w/ Optical Flats, and Parallels
Calipers <sup>1</sup>	Up to 72 in	(408 + 0.08L) µin	Gage Blocks
Indicator Gages <sup>1</sup>	Up to 6 in	(14 + 0.21L) µin	Gage Blocks
Electronic Indicator Gages/ LVDT <sup>1</sup>	Up to 4 in	(9 + 0.23L) µin	Gage Blocks
Height Gages <sup>1</sup>	Up to 48 in	(31 + 0.53L) µin	Gage Blocks
Height Masters <sup>1</sup>	Up to 24 in	(28 + 0.67L) µin	Gage Blocks
Step Gages	Up to 48 in	(28 + 0.67L) µin	Gage Blocks
Length – 1D <sup>1</sup>	Up to 40 in	(6.6 + 1.2L) µin	Universal Measuring Machine
Long Gage Blocks	4 to 20 in	(3.4 + 1.2L) µin	Universal Measuring Machine
Steel Rule	Up to 72 in	2 880 µin (66 + 0.5L) µin	Gage Block Video Measuring Machine
Tapes <sup>1</sup>	Up to 25 ft	(3 600 + 0.1L) µin (133 + 0.6L) µin	Master Tape Video Measuring Machine
Plug Gages <sup>1</sup>	Up to 40 in	(6.6 + 1.2D) µin	Universal Measuring Machine
Spherical Diameters <sup>1</sup>	Up to 8 in	(7.1 + 0.87D) µin	Universal Measuring Machine
Thread Wires	Up to 0.6 in	(7.6 + 0.38D) µin	Universal Measuring Machine
Thread Plug / Set Plugs <sup>1</sup>			
Major Diameter Pitch Diameter	Up to 12 in Up to 12 in	(12 + 0.67D) µin (69 + 0.23D) µin	Universal Measuring Machine w/ Thread Wires
Thread Rings Pitch Diameter	Up to 4 in	(70 + 0.3D) µin	Thread Setting Plug
Ring Gages / Internal Diameter <sup>1</sup>	(0.012 to 0.5) in (0.5 to 20) in	(5.8 + 0.64D) µin (6.1 + 1.07D) µin	Universal Measuring Machine and Ring Gage Comparator
Feeler (Thickness) Gages	Up to 0.25 in	(7.7 + 0.51L) µin	Universal Measuring Machine

## Length – Dimensional Metrology

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Gage Blocks	(0.01 to 4) in	(1.4 + 0.77L) $\mu$ in	Gage Block Comparator w/ Master Gage Blocks
Optical Comparators <sup>1</sup>	Up to 12 in	(70 + 3.3L) $\mu$ in	Glass scales
Machine Tools <sup>1</sup>	Up to 3 200 in	(2.4 + 1.3L) $\mu$ in	Laser Interferometer
Linearity Volume	Up to 24 in	50 $\mu$ m	Ball Bar System
Video Measuring Systems <sup>1</sup>	Up to 30 in	35 $\mu$ m	Glass grid
X/Y Axes	Up to 6 in	(24 + 0.8L) $\mu$ m	Z step gage
Z Axis	Up to 0.2 in	25 $\mu$ m	Reticle
PF(V)2D	Up to 6 in	53 $\mu$ m	Z step Gage
Squareness			
Sensofar (Single FOV)	2 $\mu$ m	0.031 $\mu$ m	Glass Pitch Pattern
XY	50 $\mu$ m	0.104 $\mu$ m	
Z	500 $\mu$ m	0.250 $\mu$ m	
Surface Finish	100 nm	0.005 $\mu$ m	Step Gage
	2 $\mu$ m, 10 $\mu$ m	0.050 $\mu$ m	
	Up to 500 $\mu$ m	1.2 $\mu$ m	
InspecVision 10360-4 (XY)	Table Center	14 $\mu$ m	Surface Finish Standard
	Table Edge	17 $\mu$ m	
Horizontal Measuring Machine <sup>1</sup>	(0 to 8) in	(3 + 0.75L) $\mu$ in	Gage Blocks
Coordinate Measuring Machines (CMM) <sup>1</sup>	Up to 26 in	(41 + 0.8L) $\mu$ in	Step Gage
Linear Displacement Accuracy	Up to 24.41 in	14 $\mu$ m	Step Gage (Koba)
Volumetric Performance	Up to 3 200 in	(2.4 + 1.3L) $\mu$ m	Laser Interferometer
Sphere Repeatability Probing and Scanning Form	Up to 36 in	19 $\mu$ m	Ball Bar
	(0.75 to 1) in	6.7 $\mu$ m	Sphere
	1 to 1.18 in	(12 + 0.3L) $\mu$ m	Sphere
Surface Finish Analyzers <sup>1</sup>	120 $\mu$ m at 0.03 in cut-off	3.8 $\mu$ m	Master Specimens
Surface Finish Specimen	(2 to 300) $\mu$ m	3.7 $\mu$ m	Surface Finish Analyzer
Surface Finish (RA)	Up to 500 $\mu$ m	3.9 $\mu$ m	Mitutoyo Surface Roughness Tester

## Length – Dimensional Metrology

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-) <sup>2</sup>	Reference Standard, Method, and/or Equipment
Surface Plates <sup>1,3</sup> Overall Flatness Repeat Reading	(0 to 140) in (0 to 140) in	(0.27+0.3d) µin 19 µin	Renishaw Laser Repeat-O-Meter
Vision (Z) Two Dimensions (Vision) (X & Y)	Up to 10 in Up to 11 in Up to 25 in	(64+ 4.1L) µin (45 + 1.3L) µin (60 + 2.1L) µin	View Summit 600 View Summit 600 View Summit 600
Two Dimensions (Vision)(XY – Single FOV)	Small Hole Dia. 2-8µm Up to 0.22 mm Up to 0.44 mm Up to 1.1 mm Up to 2.2 mm Up to 4.4 mm Up to 1 mm	0.2 µm (0.1 + 1.2L) µm (0.18 + 0.3L) µm (0.5 + 0.14L) µm (0.86 + 0.25L) µm (1.7 + 0.18L) µm (0.005 + 4.3L) µm	Sensofar S-Neox
Step (Z)			
Three Dimensions Single Point	Up to 67 in Up to 99 in	(12 + 0.73L) µin (78 + 3.6L) µin	Leitz Infinity Hexagon 122210
Scanning	Up to 67 in Up to 99 in	(38 + 0.42L) µin (120 + 3.6 L) µin	Leitz Infinity Hexagon 122210
Form	Up to 100 µin (100 to 500) µin	4.8 µin 53 µin	Mitutoyo RA2200 AH Roundness Tester

## Mass and Mass Related

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Rockwell Hardness Testers <sup>1</sup>	HRBw HRC Low Middle High	0.71 HRBw 0.71 HRBw 0.71 HRBw  0.71 HRC 0.71 HRC 0.71 HRC	Indirect Verification per ASTM E18 using Hardness Test Blocks
Torque	(5 to 50) ozf·in (4 to 50) lbf·in (30 to 400) lbf·in (80 to 1 000) lbf·in (20 to 250) lbf·ft (60 to 600) lbf·ft	0.45% of reading 0.37% of reading 0.29% of reading 0.35% of reading 0.44% of reading 0.50% of reading	Torque Tester

## Mass and Mass Related

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Pressure Gages Pressure Transducers <sup>1</sup>	(0 to 1) inH <sub>2</sub> O	0.005 3 inH <sub>2</sub> O	Ashcroft ATE-2 / AM2-1
	(0 to 10) inH <sub>2</sub> O (0 to 10) PSI (0 to 100) PSI (-14.7 to 200) PSI	0.011 inH <sub>2</sub> O 0.023 PSI 0.033 PSI 0.16 PSI	
	(0 to 1 000) PSI (0 to 3 000) PSI (0 to 10 000) PSI	0.54 PSI 2.5 PSI 8.8 PSI	Fluke 525A / 700 Series

## Thermodynamic

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Temperature - Measure	(-197 to -38) °C (-38 to 0) °C (0 to 157) °C (157 to 232) °C (232 to 420) °C (420 to 660) °C	0.03 °C 0.03 °C 0.044 °C 0.045 °C 0.054 °C 0.071 °C	Fluke 5609 with Fluke 914X-P
	(-197 to -38) °C (-38 to 0) °C (0 to 157) °C (157 to 232) °C (232 to 420) °C (420 to 660) °C	0.029 °C 0.029 °C 0.042 °C 0.042 °C 0.046 °C 0.058 °C	
Temperature - Source	(-25 to -12) °C (-12 to 75) °C (75 to 150) °C	0.069 °C 0.069 °C 0.084 °C	Fluke 9142
Temperature - Source	(50 to 200) °C (200 to 330) °C (330 to 540) °C (540 to 660) °C	0.092 °C 0.22 °C 0.30 °C 0.42 °C	Fluke 9144
Infrared Temperature	31 °C 50 °C 100 °C 200 °C	1.4 °C 1.4 °C 1.6 °C 1.8 °C	Omega IR Calibrator
Humidity – Source/Measure	(1 to 40) %RH (40 to 90) %RH (90 to 99) %RH	1.6%RH 1.7 %RH 2.3 %RH	Vaisala MI70 with MPH77B



## Time and Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Stop Watches Timers	1s to 24 Hr	36 ms	Helmut Klien Timometer
Frequency - Measure	0.1 Hz to 1 kHz (1 to 10) kHz (10 to 100) kHz (0.1 to 1) MHz (1 to 10) MHz (10 to 100) MHz (100 to 225) MHz	0.12 mHz + 9 uHz/Hz 0.12 mHz + 16 uHz/Hz 0.12 mHz + 0.11 mHz/Hz 0.12 mHz + 1.1 mHz/Hz 5.8 mHz + 2.6 mHz/Hz 5.8 mHz + 27 mHz/Hz 10 mHz + 80 mHz/Hz	Agilent 53131A

Calibration and Measurement Capability (CMC) is expressed in terms of the measurement parameter, measurement range, expanded uncertainty of measurement and reference standard, method, and/or equipment. The expanded uncertainty of measurement is expressed as the standard uncertainty of the measurement multiplied by a coverage factor of 2 ( $k=2$ ), corresponding to a confidence level of approximately 95%.

### Notes:

1. On-site service is available for this parameter, since on-site conditions are typically more variable than those in the laboratory, larger measurement uncertainties are expected on-site than what is reported on the accredited scope.
2. The use of (L) represents length in inches or millimeters based on unit of measure, the use of (D) represents diameter in inches, the use of (d) represents diagonal in inches
3. The expanded uncertainty for Surface Plate Overall Flatness represents the maximum closure error acceptable for Surface Plate Calibrations.
4. The expanded uncertainties for electrical parameters do not contain a contributor for a “best existing device. Reported uncertainties will reflect the resolution of the device under test.
5. This scope is formatted as part of a single document including Certificate of Accreditation No. ACT-1608.

Jason Stine, Vice President